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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812

Examiner: To be assigned

In Re PATENT APPLICATION Of:

Applicant(s) : LIANG et al.

Serial No. : 09/619,388

Filed : July 19, 2000

For : APPARATUS FOR
LOADING/UNLOADING WAFERS TO
AND FROM SEMICONDUCTOR
FABRICATION EQUIPMENT

Attorney Ref: LIE 105

STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please let us know the status of the above-identified application and when an Action may be expected. Please respond via facsimile or e-mail Tonya Harris (Docketing Manager) at tonya@rabinchamp.com.

Respectfully submitted,

Steven M. Rabin

Steven M. Rabin
Registration No. 29,102
Customer No. 23,995
Tel: (202) 371-8976
Fax: (202) 408-0924

August 28, 2003
Date

SMR:mrd

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No. 18-0002